## **EUROPEAN PATENT OFFICE**

2001350252

## **Patent Abstracts of Japan**

PUBLICATION NUMBER

PUBLICATION DATE : 21-12-01

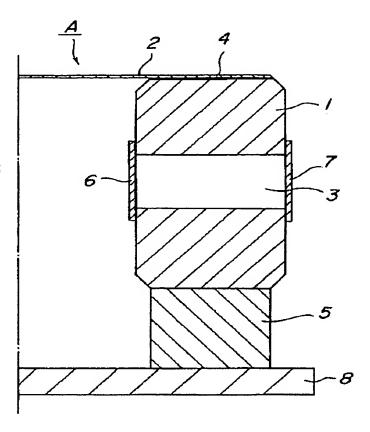
APPLICATION DATE : 05-06-00 APPLICATION NUMBER : 2000167120

APPLICANT: ASAHI KASEI ELECTRONICS CO LTD;

INVENTOR: HATADA YOSHIKATSU;

INT.CL. : G03F 1/14

TITLE : PELLICLE



ABSTRACT:

PROBLEM TO BE SOLVED: To provide a pellicle free of the generation of dust and to particularly provide a pellicle capable of preventing the generation of fine foreign matter as dust in a venthole in the pellicle and the outflow of dust from the venthole by vibration, shock, contact, etc., in the transport and handling of the pellicle.

SOLUTION: The pellicle A has a structure formed by stretching a pellicle membrane 2 on the upper edge of a pellicle frame 1 by way of an adhesive 4, piercing a venthole 3 in a prescribed position of the pellicle frame 1 and disposing filters 6, 7 on the inside and outside of the venthole 3.

COPYRIGHT: (C)2001, JPO